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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Kei-Yu Ko

Title: NITRIDE SELECTIVE AND FIELD OXIDE SELECTIVE SEMICONDUCTOR ETCHING

Attorney Docket No.: 303.696US1

PATENT APPLICATION TRANSMITTAL

BOX PATENT APPLICATION

Commissioner for Patents

Washington, D.C. 20231

We are transmitting herewith the following attached items and information (as indicated with an "X"):

Return postcard.
 Utility Patent Application under 37 CFR § 1.53(b) comprising:
 Specification (22 pgs, including claims numbered 1 through 64 and a 1 page Abstract).
 Formal Drawing(s) (7 sheets).
 Signed Declaration (3 pgs).
 Signed Power of Attorney (1 pg.)
 Check in the amount of \$2,062.00 to pay the filing fee.
 Assignment of the invention to Micron Technology, Inc. (2 pgs) and Recordation Form Cover Sheet.
 ~~Check in the amount of \$40.00 to pay the Assignment recording fee.~~

The filing fee has been calculated below as follows:

	No. Filed	No. Extra	Rate	Fee
TOTAL CLAIMS	64 - 20 =	44	x 18 =	\$792.00
INDEPENDENT CLAIMS	10 - 3 =	7	x 80 =	\$560.00
MULTIPLE DEPENDENT CLAIMS PRESENTED				\$0.00
BASIC FEE				\$710.00
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